INTERNATIONAL GEMOLOGICAL INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 16, 2026

IGI Report Number	LG848674884
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	CUSHION MODIFIED BRILLIANT
Measurements	7.90 X 5.75 X 3.83 MM

GRADING RESULTS

Carat Weight	1.32 CARAT
Color Grade	E
Clarity Grade	VS 1

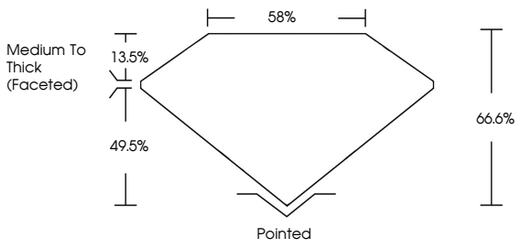
ADDITIONAL GRADING INFORMATION

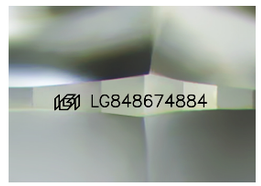
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	LG848674884

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG848674884
Report verification at igi.org

PROPORTIONS





Sample Image Used

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light

CLARITY

FL	IF	VVS 1 - 2	VS 1 - 2	SI 1 - 2	I 1 - 3
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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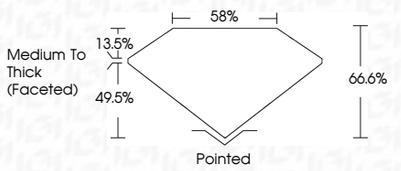
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October 16, 2026
IGI Report No LG848674884
CUSHION MODIFIED BRILLIANT
7.90 X 5.75 X 3.83 MM
Carat Weight 1.32 CARAT
Color Grade E
Clarity Grade VS 1
Depth 66.6%
Table 58%
Girdle Medium To Thick (Faceted)
Culet Pointed
Polish EXCELLENT
Symmetry EXCELLENT
Fluorescence NONE
Inscription(s) LG848674884
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